

Notice of References Cited	Application/Control No. 10/691,400	Applicant(s)/Patent Under Reexamination CUI ET AL.	
	Examiner Mai-Huong Tran	Art Unit 2818	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Kamal Kishore Goundar, Method of forming silicon carbide films, filing date: Jul 9, 2003, US pub. No. 20050009320.
	V	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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